

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

DP-300218

Application Number

Applicant(s)

POLIKARPUS, ET AL.

Filing Date

JANUARY 9, 2002

Group Art Unit

30/60/01  
10/042867  
10/042867

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KO		4,291,107	09/22/81	BARRY, ET AL.	429	104	04/15/80
KG		4,298,388	11/03/81	SACK	501	15	10/08/80
KO		5,236,569	08/17/93	MURASE, ET AL.	204	412	11/26/90
KK		5,976,335	11/02/99	KATO, ET AL.	204	425	12/05/97

## FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
KO	GB 2 294 330 A	24/04/1996	UNITED KINGDOM				✓

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KO	T.R. Armstrong & K.D. Meinhardt, "INSULATING SUBSTRATES FOR PLANAR SENSORS AND METHOD OF MANUFACTURE", March, 1999, 3 pages

EXAMINER

*[Signature]*

DATE CONSIDERED

12/15/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.